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(54) Title: HIGH BRIGHTNESS DIODE OUTPUT METHODS AND DEVICES

(57) Abstract: Devices and methods for maintaining the brightness of laser emitter bar outputs having multiple emitters for coupling and other applications. In some embodiments, at least one brightness enhancement optic may be used in combination with a beam reformatting optic.

HIGH BRIGHTNESS DIODE OUTPUT METHODS AND DEVICES

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Field of the Invention

Optical systems and components thereof which may be used for maintaining the brightness of laser emitter bar output beams. Some embodiments may be useful for high efficiency coupling of laser emitter bar output beams or other suitable applications.

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Background

Applications requiring light energy and, in some embodiments, laser energy, may benefit from the use of solid state light sources such as laser diodes which are 15 commonly available, reliable to operate and relatively cost effective as a laser energy source. Such devices may include a plurality of laser emitters in a single bar that emit laser light simultaneously in a common direction. In addition, multiple solid state or laser emitter bars may be disposed in a stacked configuration so as to generate even higher power levels.

20 Laser diode bars are often used for communication technology devices, medical applications and other applications such as military applications where it is desirable to couple the output of all the emitters of a single solid state emitter bar or multiple bars in a stacked configuration into a single optical fiber or other optical conduit. Typically the emitters of such solid state emitter bars generate significant 25 amounts of heat during operation and are spaced from each other to allow sufficient cooling without the need for elaborate and expensive cooling systems. Such spacing improves the cooling of the bars, but may make coupling of the output beams from the multiple emitters difficult. The coupling of such output beams may require a large number of expensive optical components as well as a large area for mounting such 30 optics.

In addition, for some applications, beam reformatting optics may be used in order to further enhance the coupling of the emitter output into a desired device. However, such beam formatting optics may further complicate the coupling process and reduce the brightness of the overall output of the bar by generating gaps between 35 output beams of the individual emitters of a laser emitter bar or bars. One reason for

this is that for some beam reformatting optics the size of the beamlets passing through the beam reformatting optic must be significantly smaller than the center to center spacing of a source laser emitter bar or the like. As such, brightness may be lost in the downstream optics.

5 What has been needed are methods and devices for maintaining the brightness and power of an output of multiple emitters of a laser emitter bar after the output has been reformatted. What has also been needed are devices and methods for coupling reformatted output beams of a laser emitter bar that use fewer optical elements or components.

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Summary

15 Some embodiments of an optical system include a laser emitter bar having an output with an output axis, a brightness enhancement optic operatively coupled to the output of the laser emitter bar and a fast axis collimator disposed between the laser emitter bar and the brightness enhancement optic and operatively coupled to the output of the laser emitter bar. The optical system may also include a beam reformatting optic which is configured to individually rotate output beams of emitters of the laser emitter bar and which is disposed between the brightness enhancement 20 optic and the laser emitter bar and coupled the output of the laser emitter bar.

25 Some embodiments of a brightness enhancement optic include a faceted telescope configuration having an input surface with a plurality of adjacent input facets and an output surface with a plurality of adjacent output facets corresponding to each respective input facet. The input and output surfaces may be substantially parallel to each other and may be configured to refract substantially parallel input beams through the optic so as to exit the output facets parallel to each other and spaced closer together than the spacing of the parallel input beams.

30 Some embodiments of an optical system include a first laser emitter bar having a first output with a first output axis, a second later emitter bar having a second output with a second output axis which is oriented substantially perpendicular to the first output axis and a brightness enhancement optic operatively coupled to the first output and second output which is configured to redirect the second output to a propagation direction substantially parallel to the propagation direction of the first output and interleave the first and second outputs. The optical system may also include a first

fast axis collimator disposed between the first laser emitter bar and the brightness enhancement optic and operatively coupled to the first output of the first laser emitter bar and a second fast axis collimator disposed between the second laser emitter bar and the brightness enhancement optic and operatively coupled to the second output of the second laser emitter bar. The system may also include a first beam reformatting optic disposed between the first laser emitter bar and the brightness enhancement optic and operatively coupled to the first output of the first laser emitter bar and a second beam reformatting optic disposed between the first laser emitter bar and the brightness enhancement optic and operatively coupled to the second output of the second laser emitter bar. For some of these embodiments, the brightness enhancement optic includes a periodic interleaver having an output surface with optically transmissive sections alternating with optically reflective sections. For such embodiments, each beam of the first output of the first laser emitter bar may be directed to an optically transmissive section and each beam of the second output of the second laser emitter bar is reflected by a reflective section in a direction substantially parallel to the direction of the first output.

Some embodiments of an integrated optical lens include a lens body having a first surface and a second surface which together are configured to both focus an output of a laser emitter bar and substantially collimate an output of a laser emitter bar in a slow axis direction. For some of these embodiments, the first surface includes an aspheric lens configured to focus an output of a laser emitter bar and the second surface includes an acylindrical lens configured to substantially collimate an output of a laser emitter bar in a slow axis direction.

Some embodiments of an optical system include a laser emitter bar having an output with an output axis, a fast axis collimator operatively coupled to the output of the laser emitter bar and an integrated optical lens comprising a lens body having a first surface and a second surface which together are configured to both focus an output of a laser emitter bar and substantially collimate an output of a laser emitter bar in a slow axis direction. For some of these embodiments, the first surface of the integrated optical lens includes an aspheric lens configured to focus an output of a laser emitter bar and the second surface of the integrated optical lens includes an acylindrical lens configured to substantially collimate an output of a laser emitter bar in a slow axis direction.

Some embodiments of a method of processing an output of at least one laser emitter bar includes emitting a plurality of substantially parallel beamlets from a plurality of laser emitters, substantially collimating the beamlets in a fast axis direction, reformatting the beamlets by rotation of each beamlet and enhancing the 5 brightness of the beamlets by passing the beamlets through a brightness enhancement optic. Some of these embodiments may also include substantially collimating the beamlets in a slow axis direction.

These features of embodiments will become more apparent from the following detailed description when taken in conjunction with the accompanying exemplary 10 drawings.

Brief Description of the Drawings

FIG. 1 is a perspective view of an embodiment laser emitter bar.

15 FIG. 2 is a perspective view of an embodiment of a stacked array of laser emitter bars.

FIG. 3 shows an emission array of the laser emitter bars of the stacked array embodiment of FIG. 2.

FIG. 4A illustrates an elevation view of an embodiment of an optical system.

20 FIG. 4B illustrates a top view of the optical system of FIG. 4A.

FIG. 4C is a sectional view of the beams of the emitters of the laser emitter bar of FIGS. 4A and 4B between the fast axis collimator and the beam reformatting optic.

FIG. 4D is a sectional view of the beams of the emitters of FIGS. 4A and 4B between the beam reformatting optic and the brightness enhancement optic.

25 FIG. 4E. is a sectional view of the beams output of the brightness enhancement optic in FIGS. 4A and 4B.

FIG. 5 illustrates an embodiment of a reformatting optic.

FIG. 6 illustrates an embodiment of a beam reformatting optic.

30 FIG. 7A illustrates a top view of an embodiment of a brightness enhancement optic.

FIG. 7B illustrates a side view of the brightness enhancement optic of FIG. 7A.

FIG. 8A illustrates a top view of an embodiment of a brightness enhancement optic.

FIG. 8B illustrates a side view of the brightness enhancement optic of FIG. 8A.

FIG. 9A shows a top view of an embodiment of an integrated brightness enhancement optic and slow axis collimator.

FIG. 9B shows a side view of the integrated brightness enhancement optic and slow axis collimator embodiment of FIG. 9A.

5 FIG. 10A illustrates a top view of an embodiment of a brightness enhancement optic.

FIG. 10B illustrates a side view of the embodiment of the brightness enhancement optic of FIG. 10A.

10 FIG. 11A illustrates a top view of an embodiment of a brightness enhancement optic.

FIG. 11B illustrates a side view of the embodiment of the brightness enhancement optic of FIG. 11A.

FIG. 12 is a top view of an embodiment of an optical system embodiment having two laser emitter bars and a brightness enhancement optic.

15 FIG. 13A is a side view of an embodiment of an interleaver brightness enhancement optic.

FIG. 13B is a top view of the interleaver brightness enhancement optic embodiment of FIG. 13A.

20 FIG. 13C is a top view of the interleaver brightness enhancement optic embodiment of FIG. 13A showing the optical path of the emitter output of the first and second emitter bars through the interleaver brightness enhancement optic.

FIG. 13D illustrates the optical path of a single emitter output through the interleaver brightness enhancement optic of FIG. 13C and the resulting displacement of the optical path.

25 FIG. 14A is a top view of an embodiment of an interleaver brightness enhancement optic.

FIG. 14B is a perspective view of the interleaver brightness enhancement optic of FIG. 14A shown without one prism element and illustrating an embodiment of an interleaver surface of the other prism element.

30 FIG. 14C is a top view of the interleaver brightness enhancement optic of FIG. 14A showing the optical path of the emitter output of the first and second emitter bars.

FIG. 15A is a top view of an embodiment of an integrated optical lens.

FIG. 15B is a side view of the integrated optical lens embodiment of FIG. 15A.

FIG. 16A is a top view of an embodiment of an integrated optical lens.

FIG. 16B is a side view of the integrated optical lens embodiment of FIG. 16A.

Detailed Description

5 Embodiments discussed herein are directed to methods and devices for processing an output of emitters such as laser emitter bars or chips having one or more emitters disposed therein. Embodiments discussed herein are also directed to methods and devices for coupling an output of laser emitter bars to an optical conduit, such as an optical fiber. Such bars or chips may be mounted to or otherwise 10 incorporated into optical system embodiments by a variety of methods. For such optical packages, it is important that the output array of the chips be properly aligned, that such alignment may be carried out conveniently and accurately and that the final configuration dissipate the heat generated by the chip efficiently. For some 15 embodiments, it may be desirable to minimize the number of optical components used in an optical system in order to save space and cost of the optical system.

FIG. 1 shows a laser emitter bar 12 having an output surface 14 that includes a total of 5 emitters 16 which have optical axes that are substantially parallel to each other. Although embodiments discussed herein are generally directed to use with single emitter bars, FIGS. 2 and 3 show a stacked array 10 of 4 laser emitter bars 12 that may be used with some embodiments. Each laser emitter bar 12 has an output surface 14 that includes a total of 5 emitters 16 disposed adjacent each other. The emitters 16 of each bar 12 are disposed in a substantially linear row along a slow axis direction of the emitters 16, as indicated by arrow 18. A fast axis direction of the emitters 16 is perpendicular to the slow axis direction 18 and is indicated by arrow 20. 20 The emitters 16 are positioned or otherwise configured so as to emit light energy in output beams that propagate along an emission axis 22 which may be perpendicular to both the slow axis direction 18 and fast axis direction 20. The emission axes 22 of the emitters 16 of the stacked array may be substantially parallel to each other. 25

The laser emitter bars 12 are stacked along a fast axis direction 20 of the emitters 16 and may be stacked in a periodic and regular distribution. In the embodiment of FIG. 2, the emitters of a bottom laser emitter bar 12 are vertically separated from the emitters of an adjacent laser emitter bar 12 by a distance indicated by arrow 24 which may be referred to as the pitch of the stacked array 10. For some stacked array embodiments 10, the pitch indicated by arrow 24 may be about 1 mm to

about 3 mm, specifically, about 1.5 mm to about 2.0 mm. Such a stacked array 10 of laser emitter bars 12 and emitters 16 may allow a large amount of light energy or power to be produced in a compact device for some embodiments.

Laser emitter bar embodiments 12 may have any suitable number of emitters 16, such as about 1 emitter to about 100 emitters, more specifically, about 3 emitters to about 12 emitters. For some embodiments, each laser emitter bar 12 having about 5 emitters 16 may have an output power of about 5 Watts (W) to about 90 W, more specifically, about 15 W to about 70 W, and even more specifically, about 20 W to about 30 W. Emitters 16 may include laser diodes such as edge emitting laser diodes, vertical cavity surface emitting lasers (VCSELs) and the like. Materials for the emitters 16 of the laser emitter bar 12 may include semiconductor materials such as GaAs, InP or any other suitable laser gain medium.

Generally, the emitting aperture of a laser diode embodiment of an emitter 16 is rectangular in shape with the long dimension of the emitter 16 having a size of typically tens or hundreds of microns, while the short dimension is typically one to several microns in size. Radiation emerging from an emitter 16 diverges with the divergence angle being greater along the short emitter 16 direction. Divergence angles are lower in the direction of the long emitter 16 direction. Some embodiments of the emitters 16 may have a physical width of about 30 microns to about 300 microns, more specifically, about 50 microns to about 200 microns, and the emitters may have a height of about 1 micron to about 3 microns. Some emitter embodiments may have a cavity length of about 0.5 mm to about 10 mm, more specifically, about 1 mm to about 7 mm, and even more specifically, about 3 mm to about 6 mm. Such emitter embodiments 16 may have a divergence of light energy output of about 2 degrees to about 14 degrees, more specifically, about 4 degrees to about 12 degrees, in the slow axis direction 18 and a divergence of light energy output of about 30 degrees to about 75 degrees in the fast axis direction 20.

Some embodiments of the laser diode bars 12 may have emitters 16 that emit light energy having a wavelength of about 700 nm to about 1500 nm, more specifically, about 800 nm to about 1000 nm. Emitters 16 may emit light having a centroid or peak wavelength of about 300 nm to about 2000 nm, more specifically, of about 600 nm to about 1000 nm, including wavelengths across the near infrared spectrum. Some particular embodiments of useful emitters may emit light at a peak wavelength of about 350 nm to about 550 nm, 600 nm to about 1350 nm or about

1450 nm to about 2000 nm. Such laser diode bars may be operated in either a pulsed mode or continuous wave mode. Frequently, the output spectral band of individual emitters 16 which are not wavelength controlled (for example wavelength controlled by providing wavelength-dependent feedback from a volume index grating 5 or the like) may be about 0.5 nm to about 2.0 nm or more. Due to the variation in peak emission wavelength in addition to the spectral band for each individual emitter, the overall bandwidth of the laser emitter bar 12 may be about 2 nm to about 5 nm, for some embodiments. Stacked array 10 includes 4 laser emitter bars 12, however, other embodiments of stacked arrays 10 may have any suitable number of laser 10 emitter bars 12. Some stacked array embodiments 10 may have about 2 laser emitter bars 12 to about 30 laser emitter bars 12, more specifically, about 2 laser emitter bars 12 to about 10 laser emitter bars 12.

Referring to FIG. 3, stacked array 10 is shown with a fast axis collimator 26 in the form of a cylindrical lens array disposed over the emitters 16 of the stacked array 15 10 and configured to substantially collimate an output beam of the emitters 16 of each laser emitter bar 12 in a fast axis direction 20. Although the embodiment shown in FIG. 3 illustrates the fast axis collimator secured directly to the bars 12, the same collimating effect may be achieved with the fast axis collimator 26 secured apart from and in fixed relation to the bar or bars 12 as will be discussed in more detail below. 20 Fast axis collimator 26 may include one cylindrical lens for each laser emitter bar 12 or one or more monolithic lens arrays as well as any other suitable configuration. This fast axis collimation of the emitter output produces an output array 28 as shown wherein the light energy output 30 of each emitter 16 of each laser emitter bar 12 is substantially collimated along the fast axis 20 of the emitters 16 but continues to 25 diverge along the slow axis 18 of the emitters 16. The light energy outputs 30 of each laser emitter bar 12 may have a substantially rectangular cross section transverse to the direction of propagation and are parallel to each other so as to produce the output array 28 as shown. The arrangement discussed above with regard to the fast axis collimators 26 of the stacked array shown in FIG. 3 may also be used with regard to a 30 single emitter bar 12.

As discussed above, there remains a need for methods and devices that are suitable for maintaining the brightness and power of an output of multiple emitters of a laser emitter bar after the output has been reformatted. There also remains a need for devices and methods suitable for coupling reformatted output beams of a laser

emitter bar that use fewer optical elements or components. FIGS. 4A and 4B show an optical system 30 that includes a laser emitter bar 12 having 5 emitters 16 that may emit an output when activated and that has an output axis as shown in FIG. 2 discussed above. A brightness enhancement optic 32 is substantially aligned with the 5 output axis of the laser emitter bar 12 and is positioned and oriented so as to be operatively coupled to the output of the laser emitter bar after the emitter output has passed through a fast axis collimator 34 disposed adjacent the emitter bar 12 and operatively coupled to the output beams thereof. The fast axis collimator 34 may also be disposed between the laser emitter bar 12 and the brightness enhancement optic 10 32. The fast axis collimator serves to substantially collimate the emitter output beams of the emitters 16 in a fast axis direction. A beam reformatting optic 36 which is configured to individually rotate output beams of emitters of the laser emitter bar 12 about a longitudinal axis of each emitter beam is disposed between the brightness enhancement optic 32 and the laser emitter bar. For some embodiments, the beam 15 reformatting optic 36 may be positioned between the fast axis collimator 34 and brightness enhancement optic 32 as shown in FIGS. 4A and 4B. The beam reformatting optic 36 is also positioned and oriented so as to be operatively coupled the output of the laser emitter bar 12 that has passed through the fast axis collimator 34.

20 The brightness enhancement optic 32 is generally configured to maintain or minimize reduction of brightness of the optical system. As such, as used herein, the term brightness enhancement or other similar terms are generally directed to the maintenance of brightness or the minimization of brightness reduction in the optical systems and methods discussed herein. It is understood that the device and method 25 embodiments discussed herein do not increase the level of brightness.

The optical system 30 also includes a slow axis collimator 38 which is positioned and oriented so as to be operatively coupled the output of the laser emitter bar 12 that is emitted from the brightness enhancement optic 32. The slow axis collimator 38 may be configured to substantially collimate an output of the laser 30 emitter bar in a slow axis direction. The slow axis collimator 38 may be disposed between the brightness enhancement optic 32 and a focusing optic 40. The optional focusing optics 40 may be disposed after the slow axis collimator 38 and may be positioned and oriented so as to be operatively coupled to the output of the laser emitter bar which is emitted from the slow axis collimator 38. The focusing optic 40

may be configured to focus the output from the slow axis collimator 38 into an optical conduit 41, such as an optical fiber or the like.

Embodiments of the slow axis collimator 38, focusing optic 40, and fast axis collimator 34 may have a standard configuration as a cylindrical lens, spherical lens, 5 aspherical lens or the like made from any suitable optical material or materials such as glass, quartz, silica and the like. For some embodiments, the fast axis collimator 34 may have a width that is substantially the same as or greater than the width of the laser emitter bar 12.

In operation, the laser emitter bar 12 is activated such that each emitter 16 of 10 the bar 12 emits an output beam having an optical axis substantially parallel to output beams of the other emitters 16 of the bar 12. The output beams then pass through the fast axis collimator 34 which substantially collimates each of the output beams in a fast axis direction. A sectional view of an embodiment of output beams emitted from the fast axis collimator 34 is shown in FIG. 4C which shows each of the 5 output 15 beams having a substantially horizontal orientation that is collimated in the fast axis direction as indicated by arrow 20 and still diverging in the slow axis direction, as indicated by arrow 18. After passing through the fast axis collimator 34, the output beams are then passed through the beam reformatting optic 36 which may rotate each of the output beams about 85 to about 95 degrees about a longitudinal axis of 20 each output beam and while maintaining the output beams substantially parallel to each other. This process effectively switches the fast axis orientation and slow axis orientation of the output beams such that the section view of the output beams between the beam reformatting optic 36 and the brightness enhancement optic 32 may look like the beam sections in FIG. 4D for some embodiments.

25 The beam sections in FIG. 4D have elongated slow axis components due to the divergence of the output beams in a slow axis direction between the fast axis collimator 34 and the brightness enhancement optic 32. The beam sections in the fast axis direction have remained fairly constant relative to the beam sections of FIG. 4C due to the collimation in that orientation by the fast axis collimator 34. As can be 30 seen in the section view of the output beams, there are significant gaps between adjacent beams in the fast axis direction due to the narrow profile of the beams and due to the combination of the beamlett cross sections and the de-facto apertures inherent in the beam reformatting optic itself. Specifically, the beamlett cross sections post fast axis collimator 34 are typically rectangular in overall geometry, while many of

the beam reformatting optics 36 work by reflective or refractive means often including de-facto apertures at about 45 degree orientations to the principle planes of the rectangular shape. Some re-formatting optics 36 work by other means (e.g. the Southampton multi-mirror), which still result in gaps due to manufacturing issues 5 (coating transitions, shape transitions for refractive optics etc.). These gaps may then be addressed by various brightness enhancement optic embodiments 32.

The output beams having the section profile shown in FIG. 4D then pass through the brightness enhancement optic 32 which expands each of the output 10 beams individually in the fast axis direction 20 while maintaining the beams parallel to each other and avoiding any unnecessary introduction of divergence. Some suitable brightness enhancement optics include telescope optic lens arrays discussed below. For some embodiments, the telescope lens elements of such an array may have the same or similar pitch to the pitch of the laser emitter bar 12. Such telescope lens arrays as well as other optics may expand the output beams in a fast axis direction 20 15 such that the output beam section after the brightness enhancement optic may look like the section view in FIG. 4E. In FIG. 4E, each of the output beams has been expanded by the operation of the brightness enhancement optic 32 in the fast axis direction such that the output beams are now adjacent or overlapping each other in the fast axis direction. The array of output beams that now appear more as a single 20 large output beam may then be passed through a slow axis collimating element such as the slow axis collimator 38 and then focused into the optical conduit 41 which may be an optical fiber of any suitable size and configuration.

For some embodiments, the beam reformatting optic 36 may include an optical 25 element that serves to rotate each individual beamlett of the output of the emitters 16 of the laser emitter bar 12 as discussed above. FIG. 5 illustrates an embodiment of a refractive beam reformatting optic 42 that includes an array of opposed pairs of diagonally oriented cylindrical lenses 44. Each opposed pair of lenses of the beam reformatting optic 42 may have a lateral separation or pitch that is substantially the same as the lateral separation or pitch of the individual emitters 16 of the laser emitter 30 bar 12 of the system. Each lens of an opposed pair of cylindrical lenses may also be set at an angle of about 90 degrees with respect to each other as shown in FIG. 5. The refractive beam reformatting optic 42 may be made from any suitable optical material such as glass, quartz, silica or the like. For some embodiments, the beam

reformatting optic 36 includes a refractive offset cylindrical lens array for 90 degree beam rotation of each output from each emitter element 16 of an emitter bar 12.

Some embodiments of such a refractive offset cylindrical lens array may include diagonally oriented cylindrical lens elements that are symmetrically disposed 5 on opposing parallel surfaces of a transmissive block or substrate that may be made of a refractive solid such as glass or silica. The transmissive block may be sized such that any opposing symmetrical pair of cylindrical lens elements focus at the same point or line within the body of the transmissive block. Such a configuration will rotate an incident output beam by approximately 90 degrees, such that the fast axis and 10 slow axis of the output beam are reversed. The rotation of individual output beams 16 may be useful to symmetrize the beam product and beam profile between the fast axis and slow axis and facilitates subsequent focusing or concentration of the output beams while maintaining brightness. The slant or angular orientation of the cylindrical lens elements of the beam reformatting optic may be set to an angle of about 40 15 degrees to about 50 degrees, as indicated by arrow 43 in FIG. 5. Embodiments of refractive offset cylindrical lens arrays for 90 degree beam rotation, such as beam reformatting optic 42 may include products such as produced by LIMO GmbH, Bookenburgeweg 4-8, Dortmund, Germany.

FIG. 6 shows an embodiment of a reflective or mirror based beam reformatting 20 optic 50 that also serves to rotate each individual beamlett of the emitters 16 of the laser emitter bar 12 about a longitudinal axis of each beamlett. The reflective beam reformatting optic 50 includes a plurality of mirror pairs 52 set at 45 degrees to an optical path 54 of an incident beamlett that generate two sequential reflections that rotate each beamlett individually about a longitudinal axis of the output beam and 25 relative to adjacent parallel propagating beamlett as shown by arrows 56. The mirrors 52 may be made from a high strength stable material and may include any suitable highly reflective coating or material to enhance reflectance of the surfaces. The amount of rotation about the beamlett axis may vary, but some embodiments may rotate each beamlett in the same direction and in substantially the same amount, for 30 example rotation by about 80 degrees to about 100 degrees, more specifically, about 85 degrees to about 95 degrees.

The brightness enhancement optic 32 for the system of FIG. 4A and 4B may include a variety of configurations that serve to maintain the brightness of an output of the emitters of a laser emitter bar. Some embodiments of brightness enhancement

optics 32 may serve to fill in gaps between individual beamlets of the output of emitters of laser emitter bars, particularly after the output has been reformatted by a beam reformatting optic as discussed above. Some embodiments of brightness enhancement optics 32 serve to expand beamlets of emitters so as to fill in gaps 5 between adjacent beamlets and may also serve to improve the collimation or reduce divergence of each beamlet. Some embodiments of brightness enhancement optics 32 may include telescope embodiments or optics. Some telescope optic embodiments of brightness enhancement optics may include a cylindrical telescope array having an opposed aligned pair of parallel cylindrical lenses for at least each 10 emitter 16 of a laser emitter bar 12 to be used with the brightness enhancement optic 32. Some embodiments of brightness enhancement optics 32 may include a faceted telescope configuration having pairs of surfaces, including an input surface having a plurality of sequential facets and an output surface having a plurality of corresponding sequential facets disposed closer together than the facets of the first surface.

15 FIGS. 7A and 7B show a brightness enhancement optic 60 that includes a cylindrical telescope array of a Keplerian type having a plurality of opposed aligned pairs of parallel cylindrical lenses 62 disposed with an optical axis parallel and next to that of each adjacent pair of opposed aligned parallel cylindrical lenses. Each 20 cylindrical lens of the opposed aligned pairs of parallel cylindrical lenses for the embodiment shown is a convex cylindrical lens. The cylindrical lenses are oriented with the convex portion disposed away from an optic body 64 forming an outer surface of the optic. The focal length and relative spacing of an input lens and output lens of each opposed pair of lenses may be configured to produce an expansion or power of a desired amount while maintaining each of the output beams substantially parallel to 25 each other and without introducing divergence of the beams.

As illustrated by the arrows 66 in FIG. 7A, an incident beamlet from the laser emitter bar 12 is expanded laterally in a fast axis direction 20 by converging through a focal point due to the lensing of the convex input lens of the input surface. The input beam then re-expands within the optic past the focal point until the beam is re-collimated by the corresponding output lens which is also convex. The expansion 30 may also reduce divergence of the beam and improve collimation so as to enhance the retention of the brightness. There is no appreciable net impact on divergence in the slow axis direction due to optic 60. The lenses of each side of the optic are substantially parallel to each other and may have a spacing or pitch that is

substantially the same as the pitch of the individual emitters 16 of the laser emitter bar embodiment 12 coupled thereto. For some embodiments, the pitch of the lenses 62 may be about 0.3 mm to about 1.5 mm, more specifically, about 0.4 mm to about 1.2 mm. The optic 60 may be made from any suitable optical material including glass, 5 quartz, silica or the like. Outer surfaces of the lenses 62 of the optic 60 may include any suitable anti-reflective coating or material in order to enhance transmission of light energy through the optic. For some embodiments, the power of the telescope elements of the optic 60 may be about 1.2 power to about 2.4 power, more specifically, about 1.4 power to about 1.7 power.

FIGS. 8A and 8B show an embodiment of a brightness enhancement optic 70 that includes a cylindrical telescope array of a Galilean type that may be similar in some respects to the Keplerian array of the embodiment shown in FIGS. 7A and 7B and discussed above. As shown in FIGS. 8A and 8B, the cylindrical lenses 72 on the input side of the optic 70 are concave instead of the convex lenses in the input array 15 of lenses on optic 60 shown in FIGS. 7A and 7B. Once again, the focal length and relative spacing of an input lens and output lens of each opposed pair of lenses may be configured to produce an expansion or power of a desired amount while maintaining each of the output beams substantially parallel to each other and without introducing divergence of the beams. In some cases, the materials, dimensions and 20 features of the enhancement optic 70 may also be the same as those of the embodiment 60 of FIGS. 7A and 7B. As shown in FIG. 8A, an incident beam indicated by the parallel arrows is refracted by the input concave lens of the input surface. The refraction of the input lens causes the beam to diverge within the optic 70 as indicated by the arrows within the optic 70. The beam is then re-collimated by 25 the corresponding output lens on the output surface so as to expand the beam in a fast axis direction while maintaining the divergence of each output beam. There is no appreciable net impact on divergence in the slow axis direction due to optic 70.

FIGS. 9A and 9B illustrate an embodiment of a brightness enhancement optic 80 that may have some of the same features, dimensions and materials as those of 30 the optic embodiment 70 of FIGS. 8A and 8B. However, brightness enhancement optic 80 of FIGS. 9A and 9B includes a lensing configuration superimposed on an output surface thereof that is configured to serve as a slow axis collimator. The slow axis collimator lensing of the output surface may be used to replace the separate slow axis collimator optic 38 shown in FIGS. 4A and 4B. In such embodiments, the

brightness enhancement optic 80 would take the place of the brightness enhancement optic 32 and slow axis collimator 38. As shown in FIGS. 8A and 8B, an output surface 82 of the optic 80 includes a cylindrical lensing configuration superimposed onto the output lenses 84 of the opposed aligned pairs of cylindrical lenses. In this 5 configuration, each of the output lenses of the aligned pairs of lenses is curved in a lens configuration so as to produce convergence in a slow axis direction. The focal length of the lensing of the output surface 82 may be selected to efficiently collimate the output beams of the system to a desired level. The cylindrical lensing of the output surface 82 serves to substantially collimate output of the laser emitter bar 12 in 10 a slow axis direction while the opposed aligned pairs of parallel cylindrical lenses serve to enhance or maintain the brightness of the beam output by expanding the beams in a fast axis direction as discussed above with regard to optic embodiment 70. For some embodiments, the focal length of the lensing of the output surface for slow 15 axis collimation may be about 5 mm to about 50 mm, more specifically, about 10 mm to about 20 mm.

FIGS. 10A and 10B show a brightness enhancement optic 90 having a faceted telescope or plane parallel plate configuration. The faceted configuration of the optic 90 has an input surface 92 with a plurality of adjacent input facets 94 and an output surface 96 with a plurality of adjacent output facets 98 corresponding to each 20 respective input facet 96. The paired input and output facets 94 and 98 may be parallel to each other and configured to refract substantially parallel input beams through the optic 90 such that the beams exit the output facets parallel to each other so as to maintain the divergence of the input beams. The output beams are spaced closer together than the spacing of the parallel input beams as shown by the arrows 25 100 of FIG. 10A. The closer spacing of the adjacent output beams of the emitters 16 may be used to maintain the brightness of the system for more efficient coupling and other applications. For some embodiments, a radius that the input facets 94 lie on and a radius that the output facets lie on, in conjunction with the material of the optic 90 and spacing of the paired facets may be selected to produce a desired amount of 30 compression of adjacent output beams. For some embodiments, the optic 90 may be configured such that incident beams having a fill factor of about 40% to about 80%, may be laterally displaced or otherwise compressed to a fill factor of about 80% to about 100%. The fill factor measurement discussed herein refers to the amount of illuminated area within the overall beam profile of all the output beams. For example,

the fill factor of the beam profile shown in FIG. 4D may be about 30% whereas the fill factor in the beam profile or section shown in FIG. 4E may be about 90%. There is no appreciable net impact on divergence in the slow axis direction due to optic 90.

For some embodiments of optic 90, each corresponding facet pair may include 5 a pair of corresponding cylindrical lenses on the input and output facet surfaces of the optic as shown in the embodiment 110 of FIGS. 11A and 11B. The input surface 112 and output surface 114 of the opposed paired cylindrical lenses 116 and 118 may be substantially aligned to each other and configured to refract substantially parallel input beams through the optic such that the beams exit the output facets parallel to each 10 other and spaced closer together than the spacing of the parallel input beams as shown by the arrows 120 of FIG. 11A. For the embodiment 110 shown, the output beams are neither expanded nor compressed in a fast axis direction 20 as shown by the beams passing through the lens pairs of the optic 110, which are configured with a power of about 1. The beams may also be collimated or have reduced divergence 15 relative to the input beams due to the telescopic effect of the paired cylindrical lenses 116 and 118. For some embodiments, the pitch or spacing of the lenses or facets of the input surface may be about 0.3 mm to about 1.5 mm, more specifically, about 0.4 mm to about 1.2 mm. The optic 110 may be made from any suitable optical material including glass, quartz, silica or the like. Outer surfaces of the lenses of the optic may 20 include any suitable anti-reflective coating or material in order to enhance transmission of light energy through the optic. Although the lens pairs of optic 110 shown have a power of about 1, the power of the telescope lens pairs of each facet of the optic 110 may have a power of about 0.5 power to about 1.5 power. Also, for some embodiments, a radius that the input lenses 116 lie on and a radius that the 25 output lenses 118 lie on, in conjunction with the material of the optic 90 and spacing of the paired lenses 116 and 118 may be selected to produce a desired amount of compression of adjacent output beams in conjunction with the expansion or compression due to the lens pairs of the optic 110. For some embodiments, the optic 110 may be configured such that incident beams having a fill factor of about 40% to 30% about 80%, may be laterally displaced, compressed and/or expanded to a fill factor of about 80% to about 100%. There is no appreciable net impact on divergence in the slow axis direction due to optic 110.

For some embodiments, a method of controlling an output of at least one laser emitter bar 12 using some of the optic embodiments discussed herein, may include

emitting a plurality of substantially parallel beamlets from a plurality of laser emitters 16 of a laser emitter bar. The beamlets may be substantially collimated in a fast axis direction by the fast axis collimator which is operatively coupled to the output of the laser emitter bar 12. The output beamlets may then be reformatted by a beam 5 reformatting optic 36 which may be configured to rotate each beamlett on a longitudinal axis thereof. Each beamlett may be rotated relative to adjacent beamlets while maintaining the position of the center or longitudinal axis of the beamlett relative to the centers or longitudinal axes of adjacent beamlets. The brightness of the beamlets overall may be enhanced or otherwise substantially maintained by passing 10 the beamlets through a brightness enhancement optic 32, such as any of the brightness enhancement optics discussed herein. For some embodiments, the output beams may be substantially collimated in a slow axis direction by passing the beamlets through the slow axis collimator 38. For some embodiments, the output beams may be focused to a focal spot or pattern suitable for coupling into a 15 transmitting core or the like of an optical conduit 41 by passing the beamlets through the focusing optics 40. Suitable optical conduits for coupling of the focused output beam of the laser emitter bar may include optical fibers, hollow reflectors, aligned mirror arrays or the like.

Another embodiment of an optical system for managing the output of a laser 20 emitter bar 12 is shown in FIG. 12. The optical system embodiment 130 includes a first laser emitter bar 132 having a first output with a first output axis 134. A second later emitter bar 136 having a second output with a second output axis 138 is positioned such that the second output axis is substantially perpendicular to the first output axis 134. A brightness enhancement optic 140 is positioned and oriented so 25 as to be operatively coupled to the first output and second output. The brightness enhancement optic 140 is configured to redirect the second output to a propagation direction substantially parallel to the propagation direction of the first output and interleave the first and second outputs from the respective first and second laser emitter bars as shown by arrows 142. A first fast axis collimator 144 is disposed 30 between the first laser emitter bar 132 and the brightness enhancement optic 140 and is positioned and oriented so as to be operatively coupled to the first output of the first laser emitter bar 132. A second fast axis collimator 146 is disposed between the second laser emitter bar 136 and the brightness enhancement optic 140 and is positioned and oriented so as to be operatively coupled to the second output of the

second laser emitter bar 136. A first beam reformatting optic 148 may be disposed between the first laser emitter bar 132 and the brightness enhancement optic 140 and is positioned and oriented so as to be operatively coupled to the first output of the first laser emitter bar 132. A second beam reformatting optic 150 is disposed between the 5 second laser emitter bar 136 and the brightness enhancement optic 140. The second beam reformatting optic 150 is positioned and oriented such that it is operatively coupled to the second output of the second laser emitter bar 136.

For some embodiments, the system 130 includes a slow axis collimator 152 which is positioned and oriented so as to be operatively coupled to the first and 10 second outputs of the first and second laser emitter bars 132 and 136 respectively. For some embodiments, the system includes a focusing optic 154 or optics positioned and oriented to be operatively coupled to an output of the brightness enhancement optic and configured to focus the output into an optical conduit 156, such as an optical fiber or the like. For some embodiments, the brightness enhancement optic 140 15 includes a periodic interleaver, as shown in more detail in FIGS. 13A - 13D. The periodic interleaver 140 has an input surface 157 that may include an anti-reflective coating and an output surface 158 with optically transmissive sections 160 alternating with optically reflective sections 162. In use, each beam of the first output of the first laser emitter bar 132 is directed to an optically transmissive section of the interleaver 20 and each beam of the second output of the second laser emitter bar 136 is reflected by a reflective section in a direction substantially parallel to the direction of the first output as shown by the arrows 142 in FIG. 12.

For some embodiments, the optically transmissive sections 160 and optically reflective sections 162 of the periodic interleaver 140 are configured as parallel stripes of substantially equal width having a pitch that may be substantially the same pitch as the pitch of the laser emitter bar emitters multiplied by a factor of about 1.40 to about 25 1.42, or about the value of the square root of two in order to compensate for the angular orientation of the incident beams with respect to the surface of the interleaver 140. For some embodiments, a width of the optically reflective sections 162 and optically transmissive sections 160 may be substantially equal to a length equal to one 30 half the pitch of the alternating sections. For some embodiments, the periodic interleaver 140 includes a plate 164 having substantially parallel surfaces which are disposed at an angle of about 45 degrees with respect to the first and second outputs 134 and 138 of the respective first and second laser emitter bars 132 and 136. For

such embodiments, the path of the output beams may be interleaved by the optic 140 as shown in FIG. 13C. As shown, the reflected beams from the second emitter bar 136 are reflected from a position disposed between and/or adjacent the transmitted beams from the first emitter bar 132.

5 In addition, the thickness of such a plate may cause lateral displacement of a beam that passes through the plate from the first laser emitter bar as shown in FIG. 13C and indicated by the arrows 141 and the symbol Δ (delta). For some embodiments, the first output may be laterally displaced by refraction through the thickness of the plate by a predetermined formula. For some embodiments, the 10 formula for lateral displacement is $\Delta = t \times (\sin(\theta - \Phi) / \cos\Phi)$ where $\sin\theta = n \sin\Phi$ and where t is the thickness and n is the index of refraction of the interleaver 140. For this relation, θ and Φ are the angles relative to the surfaces of the interleaver 140 as shown in FIG. 13D.

15 In addition to the plate embodiment of the periodic interleaver, some embodiments of the periodic interleaver may include a pair of prisms, such as triangular prisms, wherein a periodic interleaver 170 is formed at a surface of the junction between a surfaces of the prisms 172 and 174 as shown in the embodiment 20 176 of FIGS. 14A - 14C. For some embodiments, the optically transmissive sections 160 and optically reflective sections 162 may be formed on one of the surfaces of the junction between the two prisms. The sections 160 and 162 formed on one or more of the surfaces of the prisms 172 and 174 may have the same or similar features, dimensions and materials as sections 160 and 162 of the periodic interleaver 140 discussed above. It may not be necessary to account for the refractive displacement Δ discussed above as the prism embodiments of interleaver 170 avoid the passage of 25 beams through the parallel plate of 140. The optical path of the beams from the first and second bars 132 and 136 and through the optic 170 can be seen in FIG. 14C. For such embodiments, the path of the output beams may be interleaved by the optic 170. As shown, the reflected beams from the second emitter bar 136 are reflected from a position disposed between and/or adjacent the transmitted beams from the first 30 emitter bar 132. Either optic 140 or 170 may be used with the system 130 shown in FIG. 12.

As discussed above, it may be desirable for some embodiments of optical systems to minimize the number of optical elements of the system, to minimize the space taken by the optical elements of the system or both. FIGS. 15A and 15 B

illustrate an integrated optical lens 180 that includes a lens body 182 having a first surface 184 and a second surface 186 which together are configured to both focus an output of a laser emitter bar and substantially collimate an output of a laser emitter bar in a slow axis direction. For some embodiments, the first surface 184 may include an aspheric lens 188 configured to focus an output of a laser emitter bar 12 and the second surface 186 may include an acylindrical lens 190 configured to substantially collimate an output of a laser emitter bar in a slow axis direction. For some embodiments, an acylindrical lens 190 of the second surface 186 may include a substantially hyperbolic shape. For some embodiments, the first surface 184 may include an input surface of the lens body 182 and the second surface 186 may include an output surface of the lens body 182. Such configurations may also be modified or reversed with regard to the lensing functions of the input surface 184 and output surface 186 of the integrated optical lens.

Referring to FIGS. 16A and 16B, an integrated lens 192 is illustrated having a lens body 194 and the same or similar features, dimensions and materials as those of the embodiment of FIGS. 15A and 15B, with the exception that the first surface 184 includes an output surface of the lens body and the second surface 186 includes an input surface of the lens body. The integrated optics 180 and 192 shown may be substituted for the focusing optics and slow axis collimator for any of the optical systems discussed above. For any of the integrated optics, the lens body may be formed by a molding process, a grinding process, a lithographic etching process or any other suitable process. In addition, the integrated lens embodiments may be made from any suitable optical material such as glass, quartz, silica or the like.

Such integrated optics may be incorporated into any of the optical system embodiments discussed herein. For example, an optical system (not shown) may include a laser emitter bar 12 having an output with an output axis, a fast axis collimator 34 operatively coupled to the output of the laser emitter bar 12 and an integrated optical lens 180 including a lens body 182 having a first surface and a second surface which together are configured to both focus an output of a laser emitter bar and substantially collimate an output of a laser emitter bar in a slow axis direction. For some embodiments, the first surface of the composite optical lens may include an aspheric lens configured to focus an output of a laser emitter bar and the second surface of the integrated optical lens may include an acylindrical lens configured to substantially collimate an output of a laser emitter bar in a slow axis

direction. For some embodiments, the system may further include a brightness enhancement optic 32 which is operatively coupled to the output of the laser emitter bar 12 and which is disposed between the fast axis collimator 34 and the integrated optical lens 180. For some embodiments, the system may further include a beam 5 reformatting optic 36 which is configured to individually rotate output beams of emitters of the laser emitter bar 12 and which is disposed between the brightness enhancement optic 32 and the laser emitter bar 12 and coupled the output of the laser emitter bar.

With regard to the above detailed description, like reference numerals used 10 therein refer to like elements that may have the same or similar dimensions, materials and configurations. While particular forms of embodiments have been illustrated and described, it will be apparent that various modifications can be made without departing from the spirit and scope of the embodiments of the invention. Accordingly, it is not intended that the invention be limited by the forgoing detailed description.

15

What is claimed is:

1. An optical system, comprising:

a laser emitter bar having a plurality of emitters and an output with an output axis;

a fast axis collimator operatively coupled to the output of the emitters of the laser emitter bar;

a beam reformatting optic coupled to the output of the laser emitter bar which is configured to rotate an output beam of each of the emitters of the laser emitter bar individually by about 90 degrees; and

a brightness enhancement optic operatively coupled to an output of the beam reformatting optic which is configured to expand the output beams of the emitters in the fast axis direction to fill gaps therebetween.

2. The system of claim 1 further comprising a slow axis collimator operatively coupled the output of the laser emitter bar.

3. The system of claim 2 further comprising focusing optics operatively coupled to an output of the slow axis collimator.

4. The system of claim 1 wherein the brightness enhancement optic comprises a telescope optic.

5. The system of claim 4 wherein the telescope optic comprises a cylindrical telescope array having an opposed aligned pair of parallel cylindrical lenses for the emitters of the laser emitter bar.

6. The system of claim 1 wherein the brightness enhancement optic comprises a faceted telescope configuration having a pair of surfaces, including:

an input surface having a plurality of sequential facets; and

an output surface having a plurality of corresponding sequential facets disposed closer together than the facets of the first surface.

7. A brightness enhancement optic, comprising a cylindrical telescope array having an opposed aligned pair of parallel cylindrical lenses disposed parallel and next to each adjacent pair of opposed aligned cylindrical lenses.

8. The optic of claim 7 wherein the opposed aligned pairs of parallel cylindrical lenses are both convex cylindrical lenses.

9. The optic of claim 7 wherein a first cylindrical lens of each opposed aligned pair of parallel cylindrical lenses is concave and a second lens of each opposed pair is convex.

10. The optic of claim 7 wherein an output surface of the optic comprises a lensing configuration superimposed thereon that is configured to serve as a slow axis collimator.

11. The optic of claim 10 wherein the output surface comprises a cylindrical lensing configuration superimposed onto the output lenses of the opposed aligned pairs of cylindrical lenses.

12. A brightness enhancement optic, comprising:

a faceted telescope configuration including, including

an input surface having a plurality of adjacent input facets; and

an output surface having a plurality of adjacent output facets

corresponding to each respective input facet wherein the input and output surfaces are substantially parallel to each other and are configured to refract substantially parallel input beams through the optic so as to exit the output facets parallel to each other and spaced closer together than the spacing of the parallel input beams.

13. The optic of claim 12 wherein each corresponding facet pair includes a pair of corresponding cylindrical lenses on the input and output facet surfaces.

14. An optical system, comprising:

a first laser emitter bar having a first output with a first output axis;

a second later emitter bar having a second output with a second output axis which is oriented substantially perpendicular to the first output axis;

a brightness enhancement optic operatively coupled to the first output and second output which is configured to redirect the second output to a propagation direction substantially parallel to the propagation direction of the first output and interleave the first and second outputs;

a first fast axis collimator disposed between the first laser emitter bar and the brightness enhancement optic and operatively coupled to the first output of the first laser emitter bar;

a second fast axis collimator disposed between the second laser emitter bar and the brightness enhancement optic and operatively coupled to the second output of the second laser emitter bar;

a first beam reformatting optic disposed between the first laser emitter bar and the brightness enhancement optic and operatively coupled to the first output of the first laser emitter bar; and

a second beam reformatting optic disposed between the first laser emitter bar and the brightness enhancement optic and operatively coupled to the second output of the second laser emitter bar.

15. The system of claim 14 further comprising a slow axis collimator operatively coupled the first and second outputs of the first and second laser emitter bars respectively.

16. The system of claim 14 further comprising focusing optics operatively coupled to an output of the brightness enhancement optic.

17. The system of claim 14 wherein the brightness enhancement optic comprises a periodic interleaver having an output surface with optically transmissive sections alternating with optically reflective sections and wherein each beam of the first output of the first laser emitter bar is directed to an optically transmissive section and each beam of the second output of the second laser emitter bar is reflected by a reflective section in a direction substantially parallel to the direction of the first output.

18. The system of claim 17 wherein the optically transmissive sections and optically reflective sections are configured as parallel stripes of substantially equal width having a pitch that is substantially the pitch of the laser emitter bar emitters multiplied by about 1.141 and the width of the optically reflective and transmissive sections is about one half the pitch of the sections.

19. The system of claim 17 wherein the periodic interleaver comprises a plate having substantially parallel surfaces which are disposed at an angle of about 45 degrees with respect to the first and second outputs of the respective first and second laser emitter bars.

20. The system of claim 19 wherein the first output is laterally displaced by refraction through the thickness of the plate.

21. The system of claim 17 wherein the periodic interleaver comprises a pair of prisms wherein the periodic interleaver is formed on a surface of at least one of the prisms.

22. An integrated optical lens, comprising:

a lens body having a first surface and a second surface which together are configured to both focus an output of a laser emitter bar and substantially collimate an output of a laser emitter bar in a slow axis direction.

23. The lens of claim 22 wherein the first surface comprises an aspheric lens configured to focus an output of a laser emitter bar and the second surface comprises an acylindrical lens configured to substantially collimate an output of a laser emitter bar in a slow axis direction.

24. The lens of claim 23 wherein acylindrical lens of the second surface comprises a substantially hyperbolic shape.

25. The lens of claim 23 wherein the first surface comprises an input surface of the lens body and the second surface comprises an output surface of the lens body.

26. The lens of claim 23 wherein the first surface comprises an output surface of the lens body and the second surface comprises an input surface of the lens body.

27. The lens of claim 22 wherein the lens body is formed by a molding process.

28. The lens of claim 22 wherein the lens body is formed by a grinding process.

29. The lens of claim 22 wherein the lens body is formed by a lithographic etching process.

30. An optical system, comprising:

a laser emitter bar having an output with an output axis;

a fast axis collimator operatively coupled to the output of the laser

emitter bar; and

an integrated optical lens comprising a lens body having a first surface and a second surface which together are configured to both focus an output of a laser emitter bar and substantially collimate an output of a laser emitter bar in a slow axis direction.

31. The system of claim 30 wherein the first surface of the integrated optical lens comprises an aspheric lens configured to focus an output of a laser emitter bar and the second surface of the integrated optical lens comprises an acylindrical lens configured to substantially collimate an output of a laser emitter bar in a slow axis direction.

32. The system of claim 30 further comprising a beam reformatting optic which is configured to individually rotate output beams of emitters of the laser emitter bar and which is disposed between the brightness enhancement optic and the laser emitter bar and coupled the output of the laser emitter bar.

33. The system of claim 32 further comprising a brightness enhancement optic which is operatively coupled to the output of the laser emitter bar and which is disposed between the fast axis collimator and the integrated optical lens.

34. A method of processing an output of at least one laser emitter bar, comprising:

emitting a plurality of substantially parallel beamlets from a plurality of laser emitters;

substantially collimating the beamlets in a fast axis direction;

reformatting the beamlets by rotation of each beamlett; and

enhancing the brightness of the beamlets by passing the beamlets through a brightness enhancement optic.

35. The method of claim 34 further comprising substantially collimating the beamlets in a slow axis direction.

36. The method of claim 34 further comprising focusing the beamlets to a focal spot suitable for coupling to an optical conduit.

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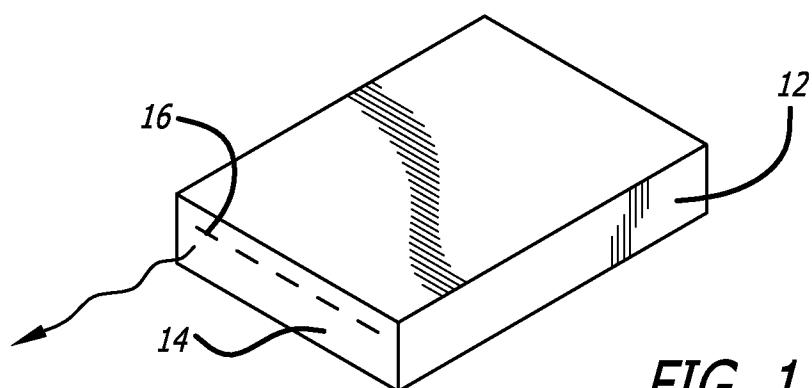


FIG. 1

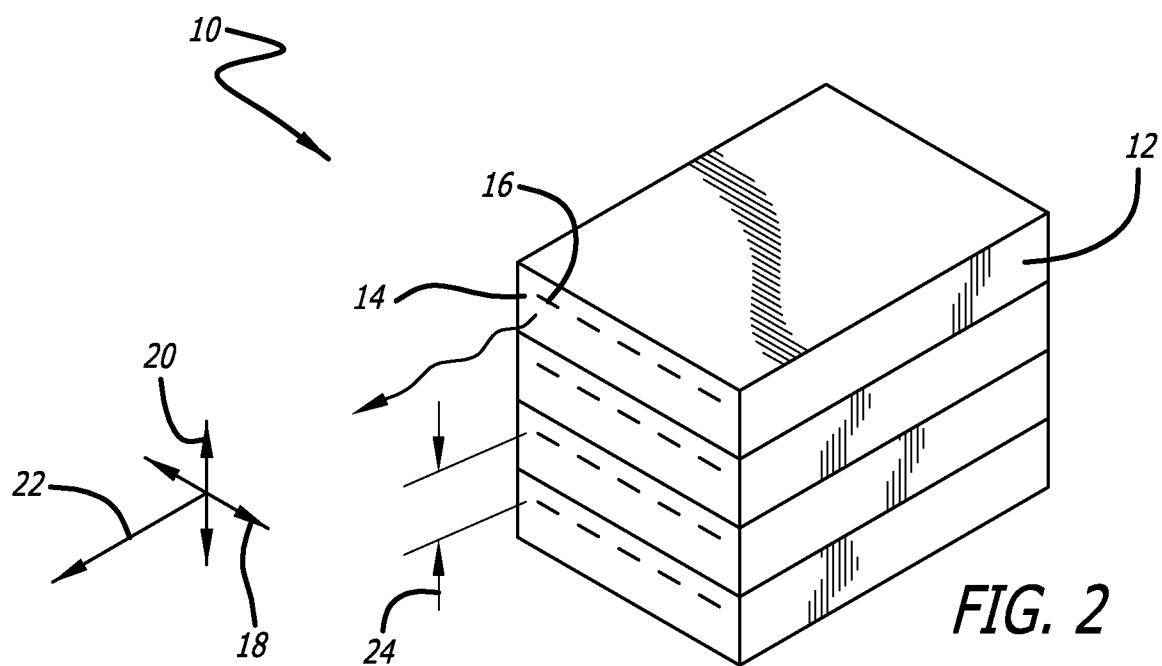


FIG. 2

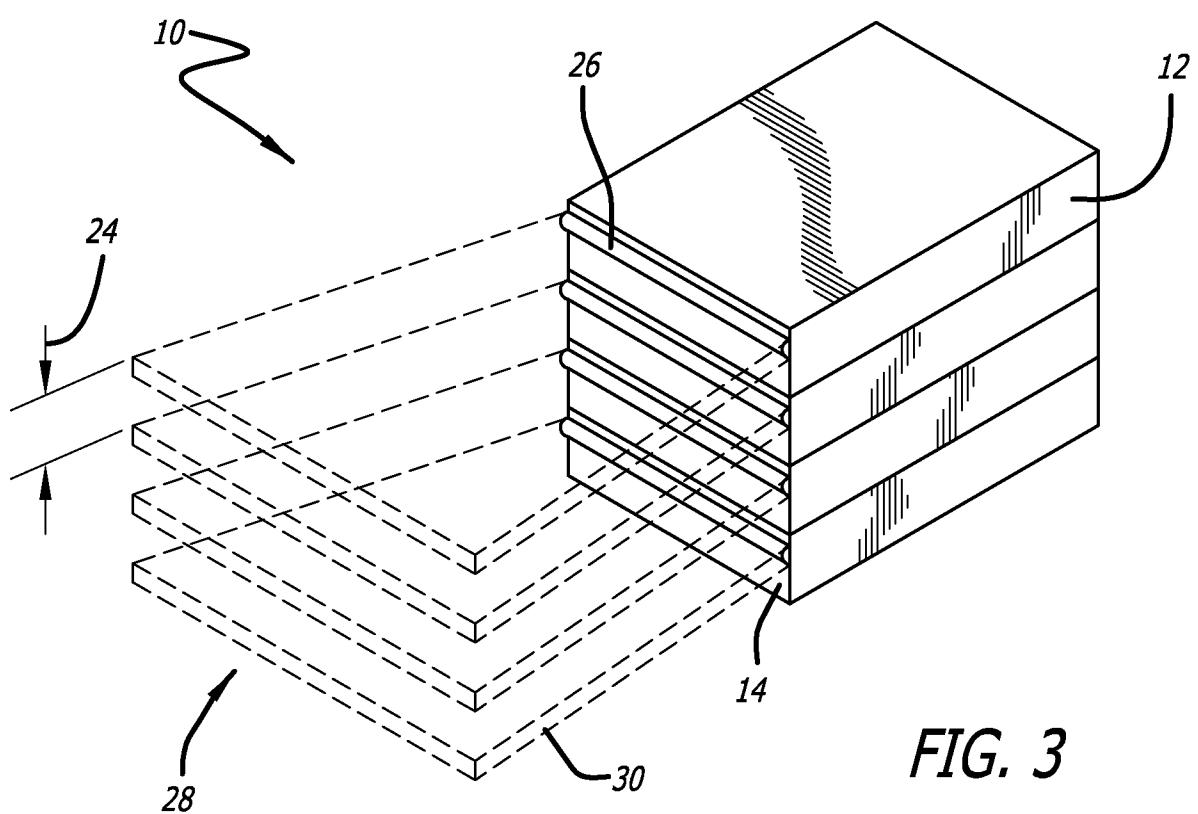


FIG. 3

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FIG. 4A

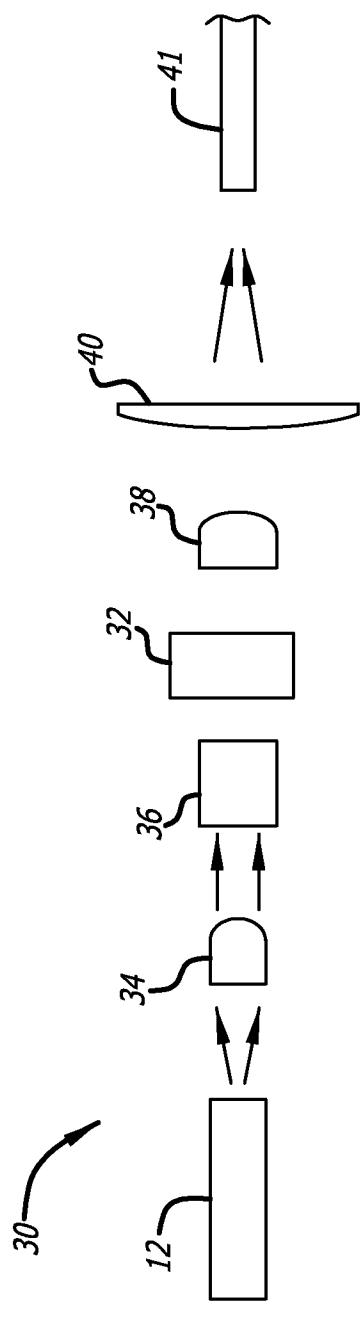
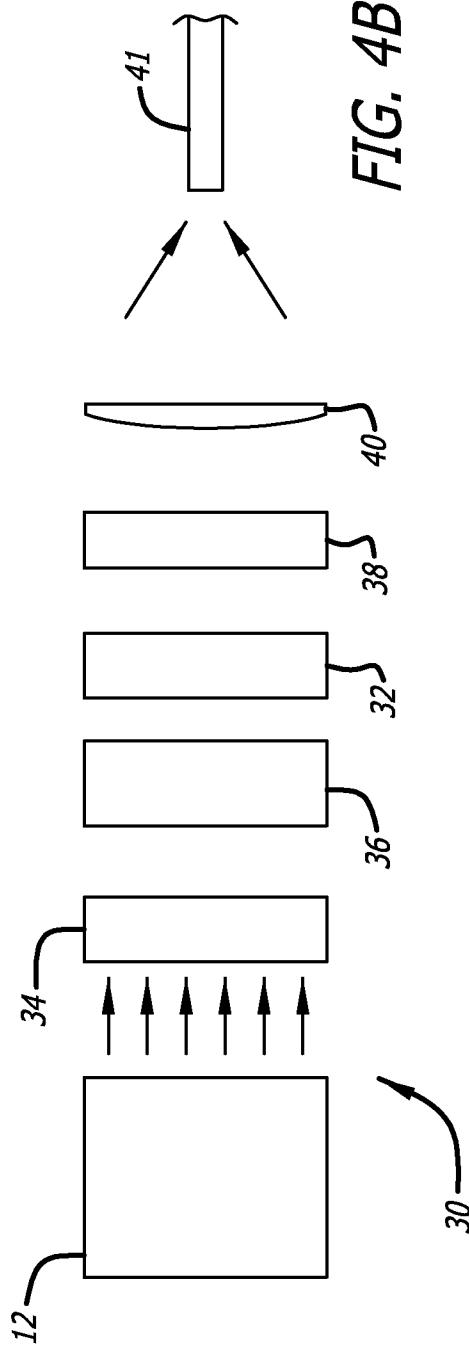


FIG. 4B



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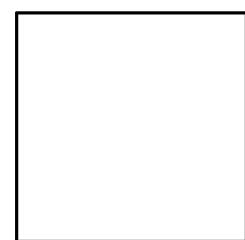
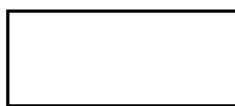
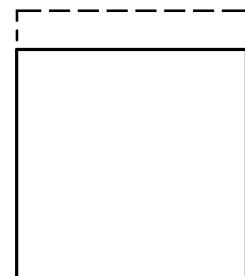
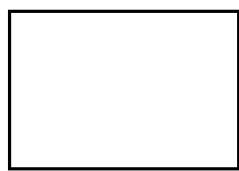
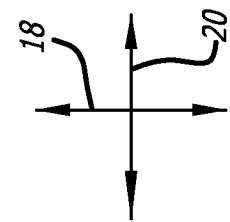
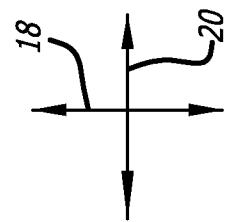
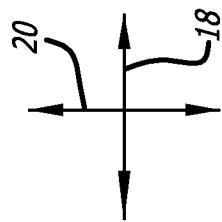
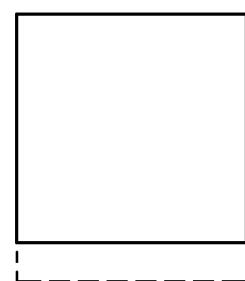
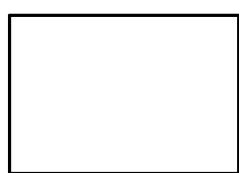
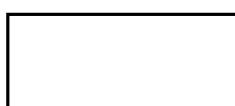
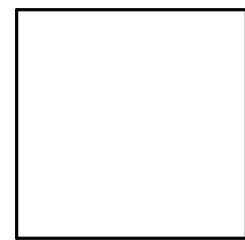
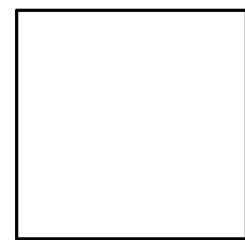


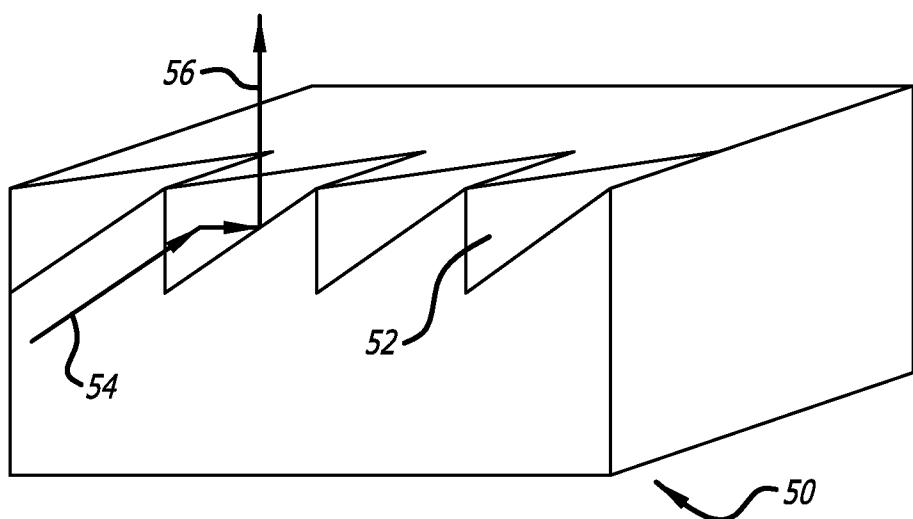
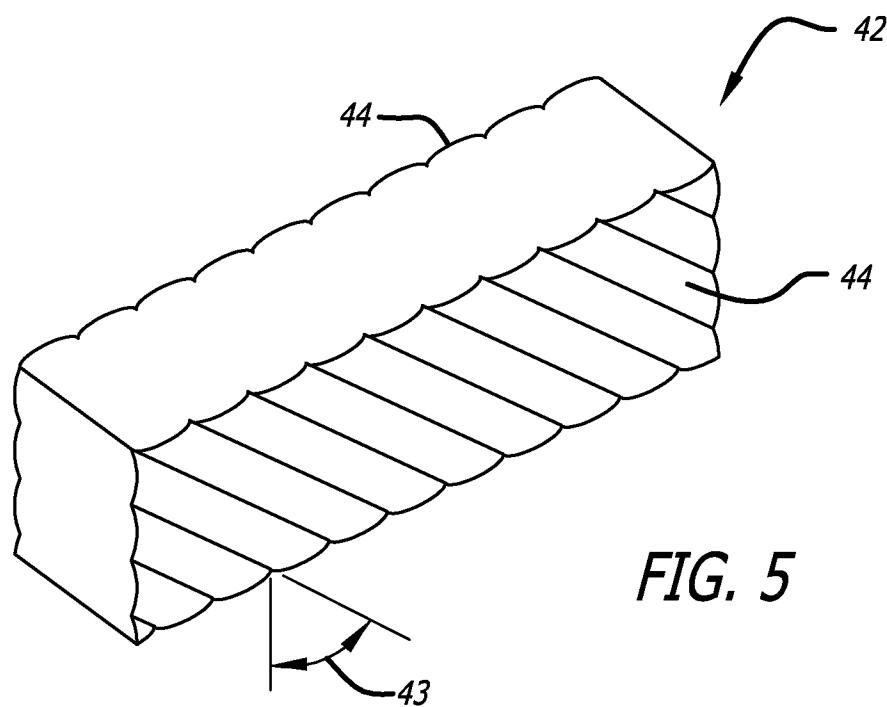
FIG. 4C



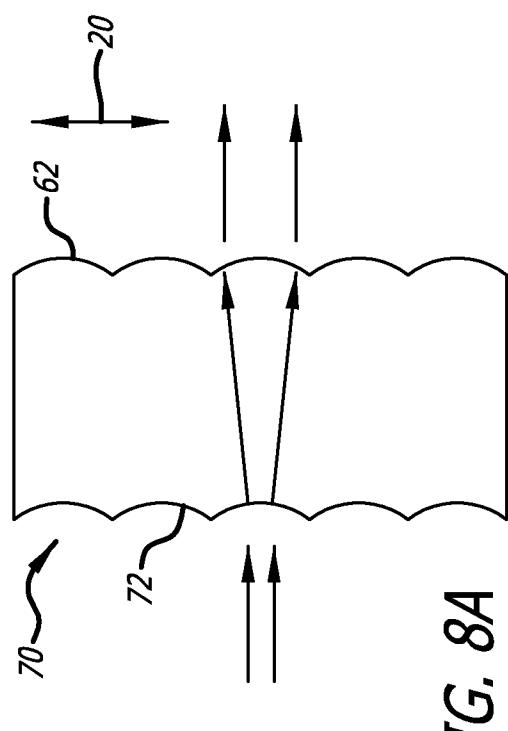
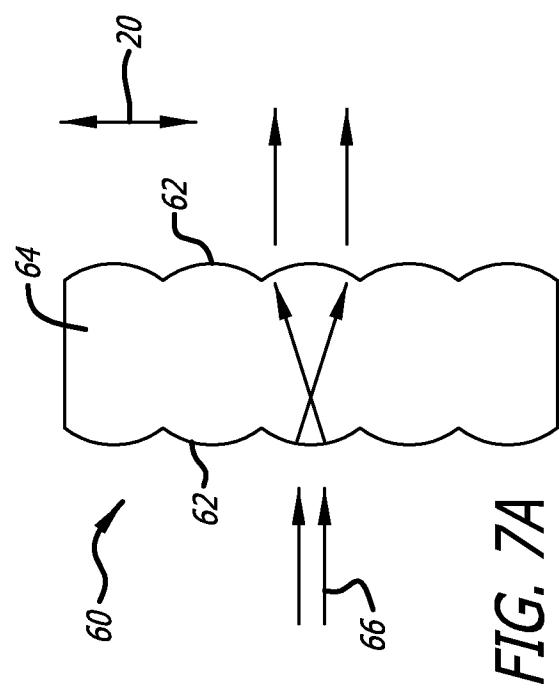
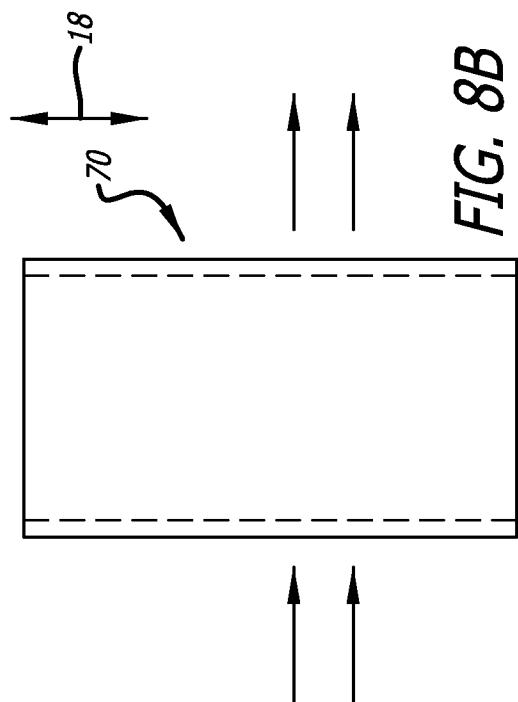
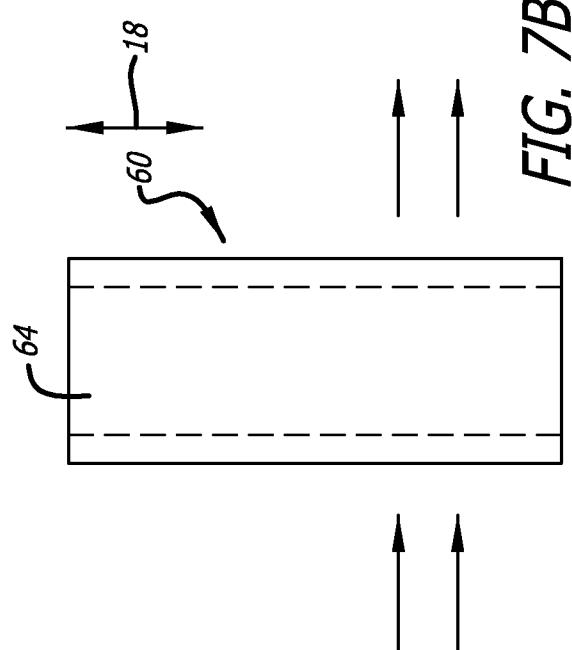
FIG. 4D



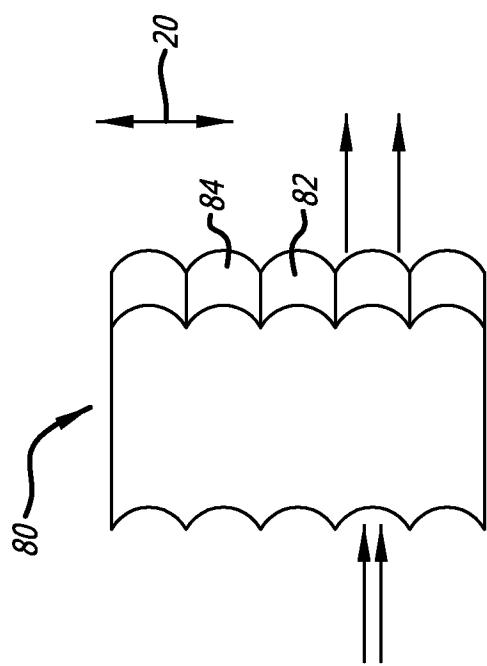
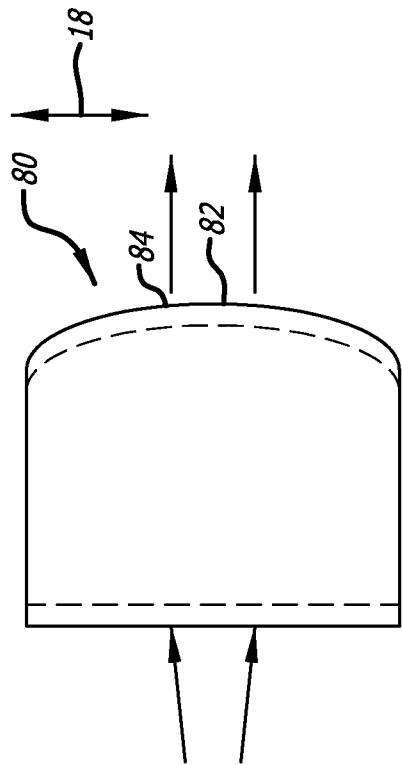
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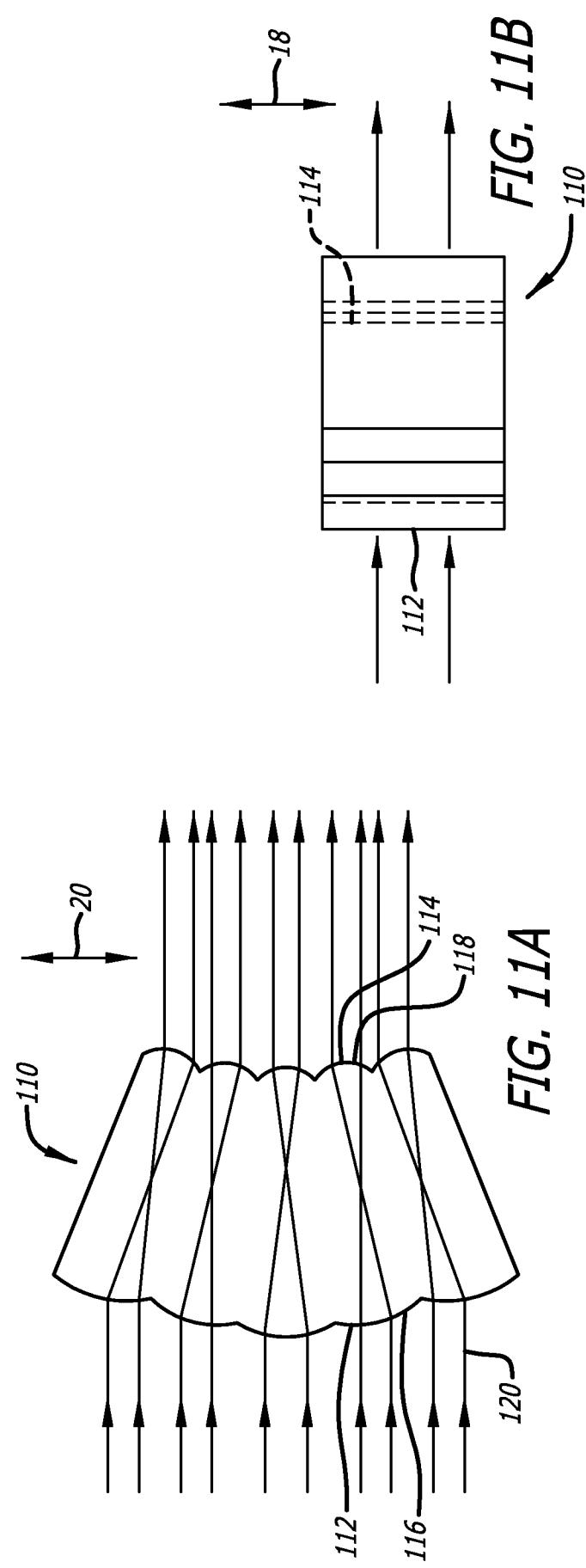
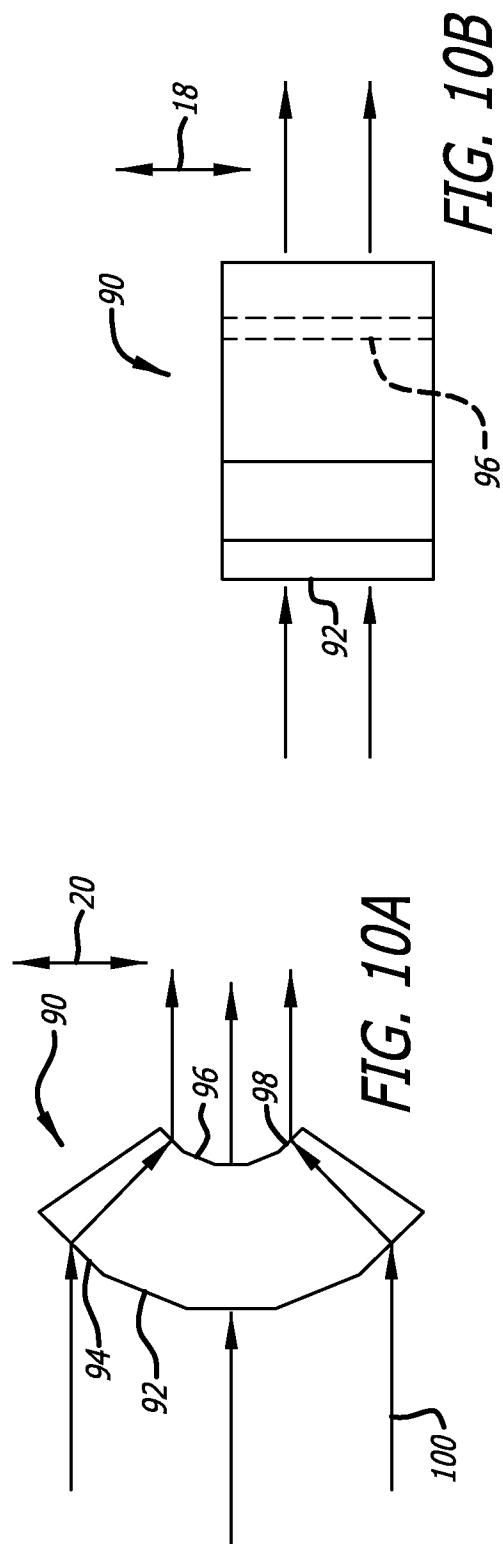
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FIG. 12

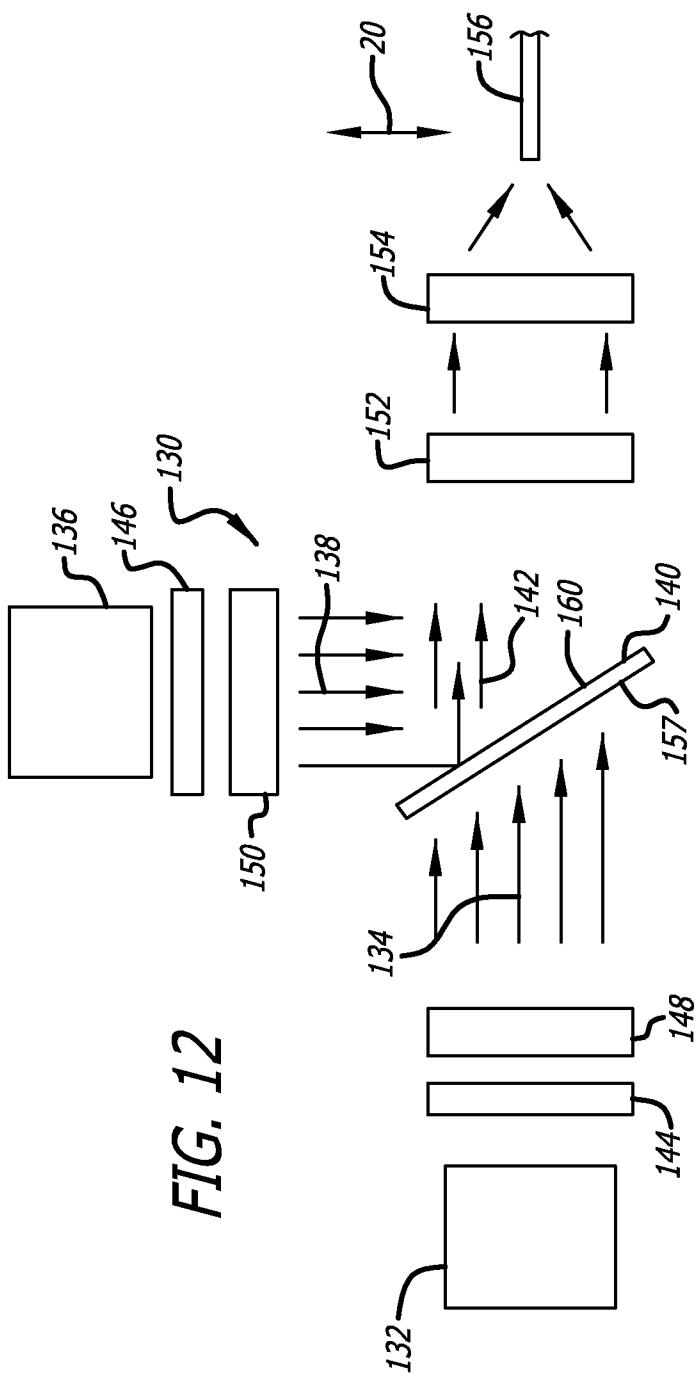
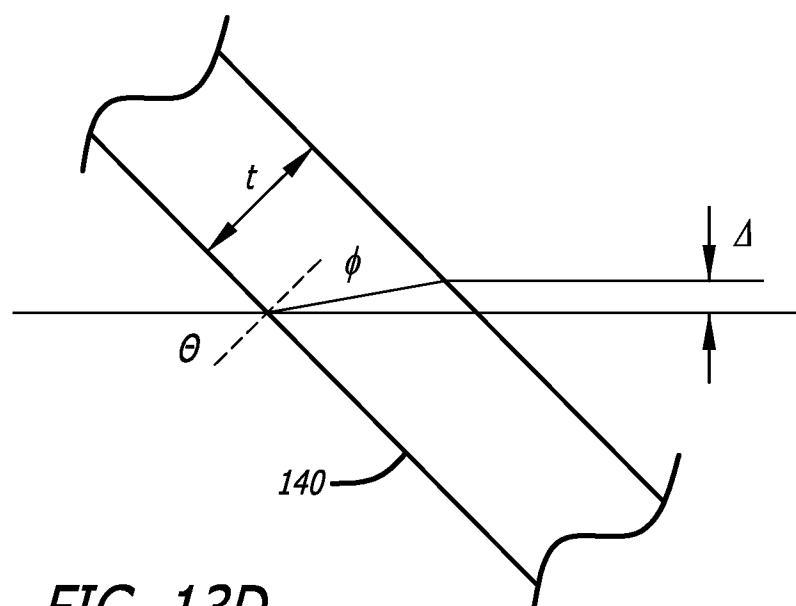
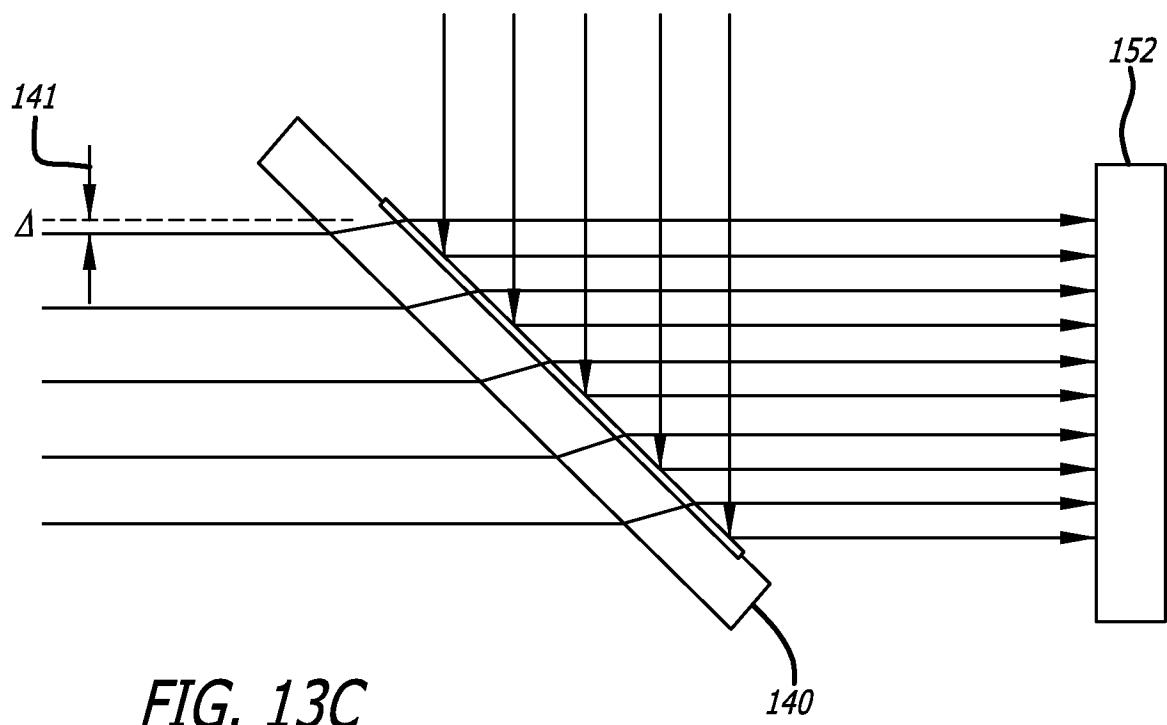


FIG. 13A



FIG. 13B

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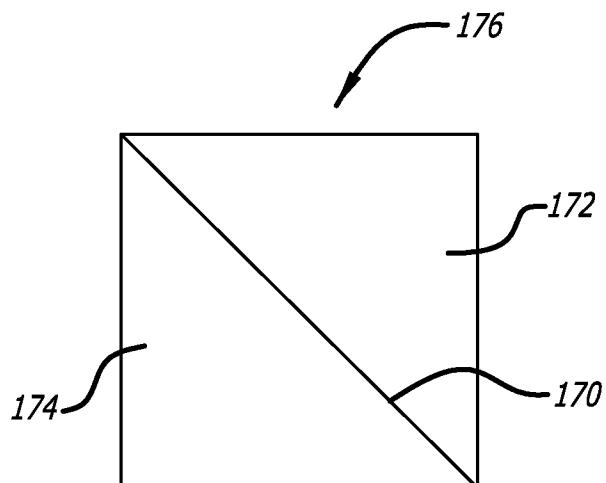


FIG. 14A

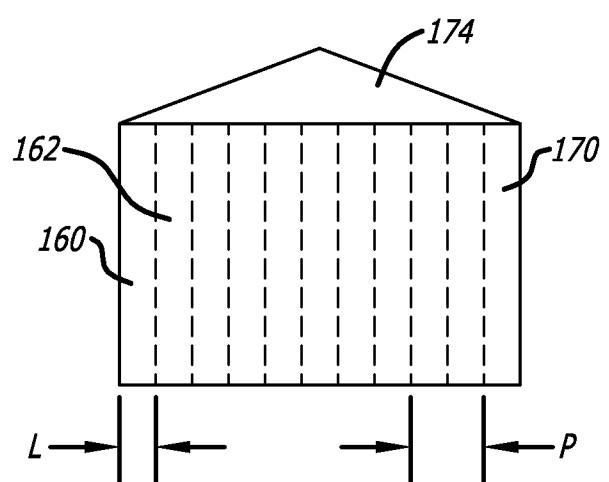


FIG. 14B

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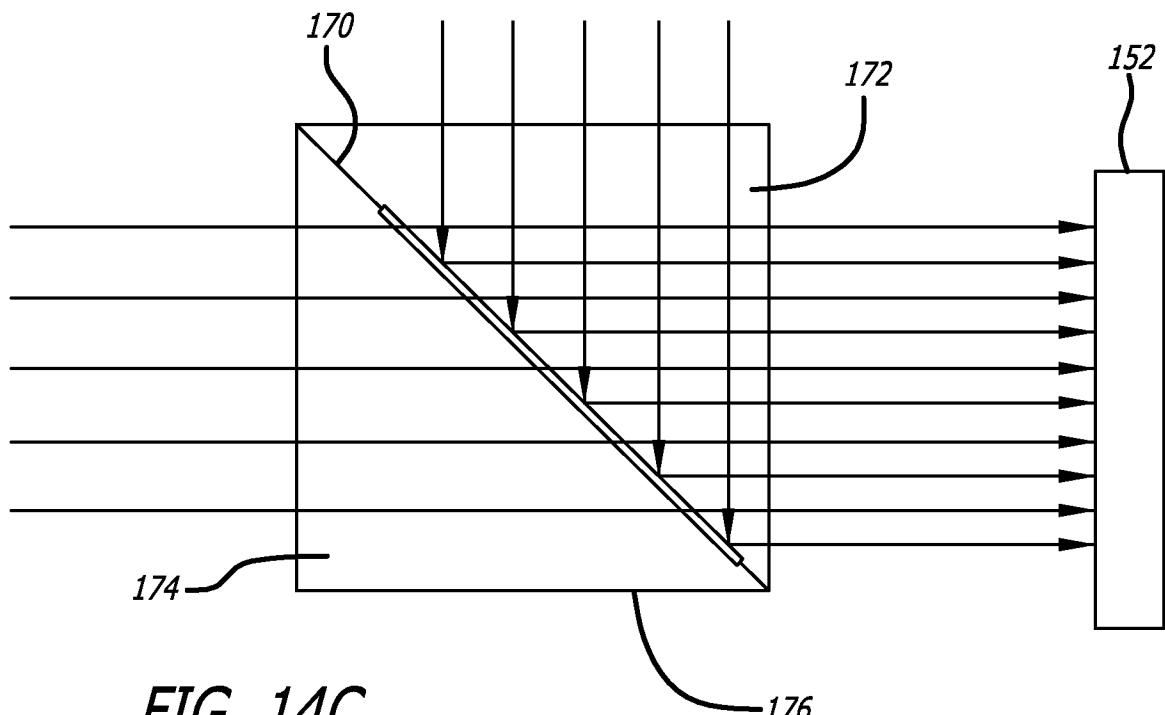


FIG. 14C

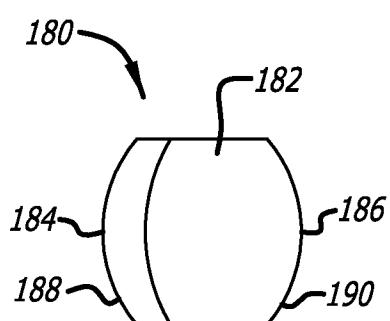


FIG. 15A

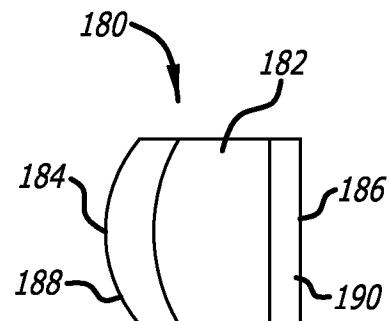


FIG. 15B

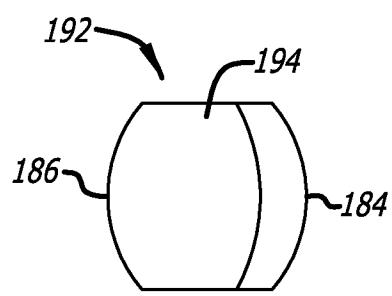


FIG. 16A

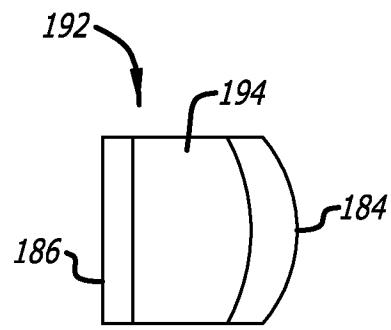


FIG. 16B